

10/586873

AP20 Rec'd PCT/PTO 21 JUL 2006
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masato TSUCHIYA et al

Appln. No.: New Application

Filed: July 21, 2006

Attorney Dkt. No.: 107242-00035

For: PROCESS CONTROL METHOD IN SPIN ETCHING AND SPIN ETCHING
APPARATUS

PRELIMINARY AMENDMENT

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: July 21, 2006

Sir:

Prior to initial examination of the application, please amend the above-identified application as shown on the following pages.

Amendment to the Specification begins on page 2.

Amendments to the claims begin on page 3.

Remarks begin on page 10.